

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent of : Attorney Docket No. 2004\_0347A  
Toshiyuki TAKIZAWA :  
Patent No. 7,786,550 :  
Issued August 31, 2010 :  
P-TYPE SEMICONDUCTOR AND :  
SEMICONDUCTOR HETERO MATERIAL :  
AND MANUFACTURING METHODS :  
THEREOF :

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**SUBMISSION OF SUPPLEMENTAL DECLARATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present supplemental Declaration is submitted to correct a number of typographical errors that were inadvertently included in the executed Declaration filed March 3, 2004. These errors occurred without deceptive intent. The supplemental Declaration changes the city of residence of the inventor from "Osaka-shi" to "Kyoto" and changes the post office address from "4-22, Kaida, Nagaokakyo, Kyoto, Japan 617-0826" to "4-22, Kaiden, Nagaokakyo, Kyoto, Japan 617-0826".

Accordingly, it is requested that the attached Supplemental Declaration be placed in the application file.

Respectfully submitted,

Toshiyuki TAKIZAWA

/David M. Ovedovitz/  
By 2010.12.13 14:17:04 -05'00'  
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